1. Record Nr. UNINA9910454355003321

Autore	Gilead Amihud
Titolo	Necessity and truthful fictions [[electronic resource]] : panenmentalist observations / / Amihud Gilead
Pubbl/distr/stampa	Amsterdam ; ; New York, : Rodopi, 2009
ISBN	1-282-59457-5 9786612594571 90-420-2920-X 1-4416-0653-X
Descrizione fisica	1 online resource (345 p.)
Collana	Value inquiry book series, , 0929-8436 ; ; 202
Disciplina	110 128
Soggetti	Possibility Panentheism God Electronic books.
Lingua di pubblicazione	Inglese
Formato	Materiale a stampa
Livello bibliografico	Monografia
Note generali	Description based upon print version of record.
Nota di bibliografia	Includes bibliographical references and index.
Nota di contenuto	Preliminary Material -- BASIC PANENMENTALIST OBSERVATIONS -- METAPHYSICAL MODALITIES -- FROM ONTOLOGY TO EPISTEMOLOGY -- NECESSITIES AND TRUTHFUL FICTIONS -- MIND AND BODY -- CONSCIOUSNESS, MEMORY, OTHER PSYCHICAL POSSIBILITIES, AND SOME VALUES -- WORKS CITED -- ABOUT THE AUTHOR -- INDEX -- VIBS.
Sommario/riassunto	This book discovers areas and themes, especially in philosophical psychology, for novel observations and investigations, the diversity of which is systematically unified within the frame of the author's original metaphysics, panenmentalism. The book demonstrates how by means of truthful fictions we may detect meaningful possibilities as well as their necessary relationships that otherwise could not be discovered.

2. Record Nr. UNINA9910350304103321

Titolo	Advances in Thin Films, Nanostructured Materials, and Coatings : Selected Papers from the 2018 International Conference on “Nanomaterials: Applications & Properties” / / edited by Alexander D. Pogrebnjak, Valentine Novosad
Pubbl/distr/stampa	Singapore : , : Springer Nature Singapore : , : Imprint : Springer, , 2019
ISBN	981-13-6133-9
Edizione	[1st ed. 2019.]
Descrizione fisica	1 online resource (XI, 386 p. 212 illus., 123 illus. in color.)
Collana	Lecture Notes in Mechanical Engineering, , 2195-4364
Disciplina	620.44
Soggetti	Surfaces (Technology) Thin films Microtechnology Microelectromechanical systems Surfaces (Physics) Nanochemistry Materials - Analysis Materials Surfaces, Interfaces and Thin Film Microsystems and MEMS Surface and Interface and Thin Film Characterization and Analytical Technique Materials Engineering
Lingua di pubblicazione	Inglese
Formato	Materiale a stampa
Livello bibliografico	Monografia
Nota di contenuto	Thin Film Deposition by Plasma Beam of a Vacuum Arc with Refractory Anodes -- Multilayer Design of CrN/MoN Superhard Protective Coatings and Their Characterisation -- Structure and Properties of Combined Multilayer Coatings Based on Alternative Triple Nitride and Binary Metallic Layers -- DSC Investigations of the Effect of Annealing Temperature on the Phase Transformation Behaviour -- Microstructure and Mechanical Properties of Multilayered -AlN/-BCN -- Mass Transfer Model of Sputtering from Rod-Like Targets for Synthesis of

Multielement Nanocoatings -- Self-Organized Growth by Sputtering and Other PVD Techniques -- On the Possibility of Training Demonstration of the Giant Magnetoresistance Effect in Higher School -- Multifractal analysis of the surfaces of protective (TiAlSiY)N, Me1-xN/CrN and Me1-xN/ZrN coatings.

Sommario/riassunto

This book highlights the latest advances in chemical and physical methods for thin-film deposition and surface engineering, including ion- and plasma-assisted processes, focusing on explaining the synthesis/processing–structure–properties relationship for a variety of thin-film systems. It covers topics such as advances in thin-film synthesis; new thin-film materials: diamond-like films, granular alloys, high-entropy alloys, oxynitrides, and intermetallic compounds; ultra-hard, wear- and oxidation-resistant and multifunctional coatings; superconducting, magnetic, semiconducting, and dielectric films; electrochemical and electroless depositions; thin-film characterization and instrumentation; and industrial applications.